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Copper deposition on TiO₂ from copper(II)hexafluoroacetylacetonate

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The authors have studied the adsorption of Cu^{II}(hfac)₂ on the surface of a model oxide system, TiO₂(110), and probed the molecular stability with respect to thermal cycling, using atomic scale imaging by scanning tunneling microscopy supported by x-ray photoemission spectroscopy. They find that at 473 K, the adsorbed metal-organic molecules begin to dissociate and release Cu atoms which aggregate and form Cu nanoparticles. These Cu nanoparticles ripen over time and the size (height) distribution develops into a bimodal distribution. Unlike other organometallic systems, which show a bimodal distribution due to enhanced nucleation or growth at surface step edges, the nanoparticles do not preferentially form at steps. The reduced mobility of the Cu islands may be related to the co-adsorbed ligands that remain in very small clusters on the surface. © 2013 American Vacuum Society. [<http://dx.doi.org/10.1116/1.4765644>]

I. INTRODUCTION

Organometallic molecules are the key precursors employed in a wide range of technologies to deposit metallic and conducting structures on a wide range of materials with potential applications in molecular electronics, biosensors, and photocatalysis. Understanding and designing the properties of the molecule–substrate and molecule–molecule interactions is crucial to making improvements in technology. This is especially true in atomic layer deposition (ALD). In ALD monolayer metal organic molecular adsorbates are sequentially reacted to coat surfaces of inorganic materials with exceptional conformity and uniformity at near atomic layer precision.¹ The method requires the formation of stable adsorbed species to block surface sites from further adsorption. This self-limiting adsorption behavior allows for a subsequent surface reaction to occur with a different gas phase species to deposit material on the surface as an oxide, metal, nitride, or sulfide. This material should be terminated in such a manner as to allow subsequent adsorption of a further cycle of organometallic molecules and their reactants leading to the perfect layer by layer construction of a desired material with atomic precision. Thermal decomposition of the metal organic precursor on the surface is a hindrance as control of the deposition process is compromised, the system may no longer be self-limiting and precision is probably lost. The deposition of elemental metals by ALD is inherently very difficult as on most oxide surface, there is a lack of suitable binding sites for the precursor molecules leading to long and unpredictable induction times, and once growth is started, there is a tendency for the metal to cluster and for nanoparticles to form.

Cu ALD is especially demanding as the relatively high surface energy of Cu and its weak interaction with many oxidic substrates leads to three-dimensional growth driven by thermodynamics. However, even at 160 K Cu adatoms deposited by physical vapor deposition are mobile and three-dimensional crystallites form on TiO₂.² Hence, many low temperature processes are of interest both to maintain the integrity of the technological substrate and to limit Cu

mobility and its tendency to form large sparse islanded arrays. In order to reduce the Cu ALD film roughness Co has been employed as a conformal seed layer to promote Cu nucleation and thus create smooth films on a variety of insulating substrates.¹ More recently, Cu ALD at low temperature has been achieved by employing a ligand exchange mechanism³ although this suffers from incorporation of Zn from the reductant. Using a three step process, Winter has developed a low temperature ALD in which the precursor exchanges Cu with formic acid to create adsorbed Cu^{II} formate which is readily reduced to Cu metal by hydrazine.⁴

Our methodology is to look at the fundamental steps in ALD and probe the molecular properties and decomposition using well defined model systems. We carefully choose materials systems where we have good control and can maintain atomically clean surfaces through surface science techniques. For this study, we chose to investigate the adsorption of copper(II)hexafluoroacetylacetonate (Cu^{II}(hfac)₂) which has been used as an precursor in the ALD of Cu.⁵ In previous work,⁶ we have used x-ray and UV photoemission spectroscopies (XPS and UPS, respectively) to characterize the molecular adsorption of Cu^{II}(hfac)₂ on titanium dioxide. The adsorption geometry of two adsorbed species was inferred from near edge x-ray adsorption fine structure (NEXAFS) experiments. These two species are composed of the hfac ligand and an hfac ligand bound to a Cu atom (Cu^I hfac) and derive from the dissociation of the parent molecule. Both fragments bond to the surface, the hfac ligand binds through the two oxygen termini on to neighboring fivefold coordinated Ti ions in the (110) surface and the Cu^I hfac through adsorption of the Cu on neighboring bridging oxygens in a square planar geometry. These molecular adsorbates block all adsorption sites and hence the adsorption is self-limiting at room temperature.

In this work, we characterize the deposition on the surface of TiO₂(110) of Cu nanoparticles from Cu^{II}(hfac)₂ and correlate the structures and key temperatures to our photoemission spectroscopies. For the work presented here, we show data obtained from the cross-linked (1 × 2) reconstructed surface which is a stable reconstruction obtained after bulk reduction of the crystal.⁷ The reconstruction is composed of

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added rows of TiO₂ that are periodically cross-linked every 10–12 lattice spacings along the $\langle 001 \rangle$ direction. The reconstruction can locally be lifted by reoxidation through exposure of oxygen to the surface at elevated temperature which allows the capture of thermally diffusing Ti interstitials and regrowth of TiO₂ at the surface.^{8–11} The cross-links of the surface structure can be used to template the growth of metal nanoparticles.¹² Both the bulk terminated (1×1) and cross-linked (1×2) TiO₂(110) surfaces expose the fivefold coordinated Ti sites where hfac adsorbs and the bridging oxygen rows where Cu^Ihfac adsorbs.

II. EXPERIMENT

The imaging experiments were performed in a WA Technology variable temperature scanning tunneling microscope (STM) system. The ultrahigh vacuum chamber is described in detail¹³ and since then has had the molecular beam removed. STM tips were formed from electrochemically etched W95%/Re5% alloy wire. Images were quantitatively analyzed using custom software to determine particle sizes as shown previously.⁶ Briefly, the particle heights are measured from the maximum height of the particle to the mean height of the terrace at the periphery of the cluster (particles at step edges will have heights averaged over each terrace while those at the edges of the image are discarded). Images were also processed using the wSXM software.¹⁴ TiO₂(110) single crystals (PIKEM, UK) were prepared by sequences of Ar⁺ sputtering, vacuum annealing, and roasting in oxygen until well ordered low energy electron diffraction (LEED) patterns were obtained. Cu^{II}(hfac)₂ (Sigma Aldrich) was deposited onto the substrate by means of a dosing tube connected to a fine leak valve. The precursor was first dehydrated by extended pumping and changed color from green to grey (as earlier studies have employed¹⁵). During deposition, the substrate was at ambient temperature (~ 300 K) and the metal organic precursor leaked into the chamber in a background pressure of $\sim 1 \times 10^{-5}$ Torr for 10 min. This corresponds to exposing the surface to approximately 6000 molecules per surface site ($\sim 5 \times 10^{-6}$ Mol cm⁻²) and hence is a large excess. The dosed crystal was annealed for 5 min at increasing temperatures in 100 K increments and then imaged by STM at 300 K. LEED patterns of the adsorbed system were not acquired due to the electron stimulated

decomposition of the precursor. The experimental setup under which the photoelectron spectroscopy was performed are described previously.⁶

III. RESULTS AND DISCUSSION

A. Room temperature molecular adsorption

The clean reconstructed TiO₂(110) surface exhibits large flat terraces prior to deposition [Fig. 1(a)] in which there are a few pits within a terrace and step edges between terraces of single atomic step height (3.25 Å). The Fig. 1(b) shows the reconstruction more clearly as added rows running in the $\langle 001 \rangle$ direction periodically linked every 8–12 lattice spacings in this direction. Pits on the terrace lead to areas of the (1×1) terminated bulk surface upon which the (1×2) reconstruction has grown. Typically some clusters of contaminants are seen in the images (~ 1 per 100 nm²) as large apparent height particles of between 5 and 10 Å. Upon adsorption of Cu^{II}(hfac)₂ at room temperature (RT, ~ 300 K), the step edges, terrace, and pit morphology remains but the fine structure of the reconstruction is obscured, Fig. 1(c). The terraces display a speckled disordered structure with a perceptible striping along the $\langle 001 \rangle$ rows. The change is characteristic of the adsorption of a molecular species on the surface. There is, however, a lack of any long range order which makes the images appear noisy. In comparison on the (1×1) terraces, a (2×1) molecular overlayer structure is observed by LEED indicative of long range order. If the adsorption of Cu^{II}(hfac)₂ on this crosslinked (1×2) surface behaves in the same way as on the bulk terminated (1×1), we expect two adsorbates to dominate—the hfac ligand adsorbed on fivefold coordinated Ti sites and Cu^Ihfac on bridging oxygen rows. Both of these adsorbates are bulky and bind bidentate to two surface ions in the substrate and so we expect a saturation coverage of a total of \sim two bound species per (1×2) surface cell comprised of either one hfac ligand and one Cu^Ihfac or two hfac ligands and a deposited Cu atom. Thus, the saturated Cu concentration of this adsorbate layer is expected to be around 2.5×10^{14} cm⁻². The as deposited images clearly show substrate step structure and the row structure of the reconstructed surfaces and hence strongly suggest that, despite the very large excess of molecules that the surface was exposed to, the adsorption

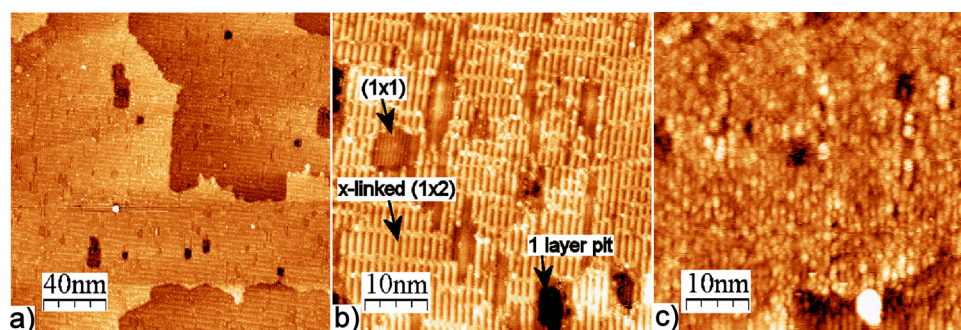


Fig. 1. (Color online) (a) Large area STM image of the clean TiO₂(110) cross-linked (1×2) surface. (b) Close up of the atomic scale structures present on this surface highlighting the near horizontal rows of cross-links and small regions of bulk termination (1×1). (c) The surface saturated with adsorbed molecules following exposure to excess Cu^{II}(hfac)₂.

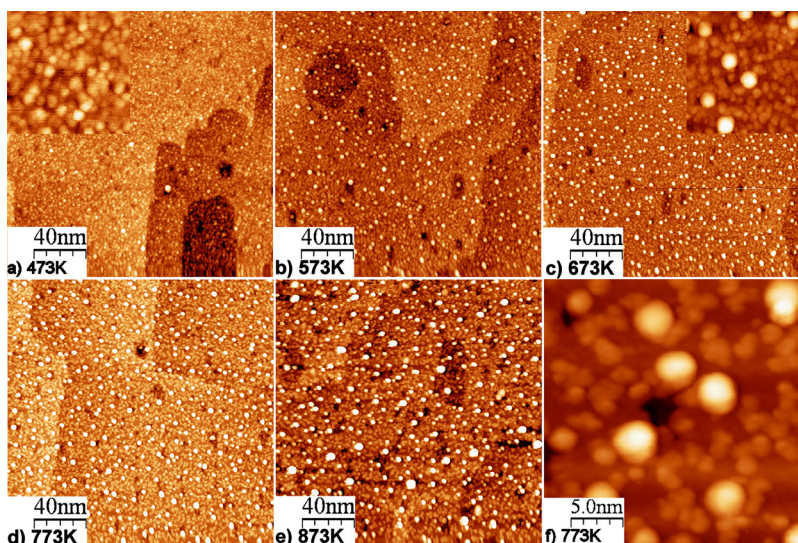


FIG. 2. (Color online) STM images of the saturated surface annealed to (a) 473 K, (b) 573 K, (c) 673 K, (d) 773 K, and (e) 873 K for 5 min. The inserts in (a) and (c) are 25 nm square images to contrast the high and uniform particle density in (a) and the development of Cu nanoparticulate islands in (c) surrounded by ligand fragments of much lower height. (f) shows a close up of the film (also 25 nm square) annealed to 773 K in which nanoparticles, small pits, and residual fragments are apparent.

behavior was self-limiting as required for an ALD process. There are also no discernible Cu islands formed from the RT adsorption, so we expect the Cu to still be bound to an hfac ligand.

B. Deposition of copper

Upon annealing the sample to higher and higher temperatures, it is possible to probe the decomposition of the adsorbed complex on the surface and to characterize the spatial arrangement of any deposited material. This capability is essential to understand the wetting or dewetting behavior of the material at the very earliest stages of growth.

In Fig. 2, we show the development of Cu nanoparticles on the surface and can image the residual ligands that are co-adsorbed. In Fig. 2(a), the sample has been annealed at 473 K and a grainy textured film arises with only a few larger islands visible [one or two of the largest of which are probably due to contaminant clusters as seen in Fig. 1(a)]. The inset shows more clearly the granular film that covers the surface. Further heating to 573 K, Fig. 2(b), sees the clear development of nanoparticles all across the surface with no preferential nucleation at step edges as is found for physical vapor deposited films.¹⁶ Through 673 K [Fig. 2(c)], 773 K [Fig. 2(d)], and 873 K [Fig. 2(e)], the density of particles begins to fall and the average size increases as the particles ripen. In this wide temperature range, a disordered secondary structure forms between the nanoparticles with a rather uniform apparent height of $\sim 3\text{--}4\text{ \AA}$ above the terraces [Fig. 2(c) inset and Fig. 2(f)]. The terraces also appear to have acquired more significant number of small pit structures which appear more compact than those present on the clean surface. By 873 K, the density of nanoparticles on the surface is dropping rapidly and it appears a small number of relatively large particles are beginning to form.

A statistical analysis of the island size distributions at each of the measured temperatures is shown in Fig. 3. The

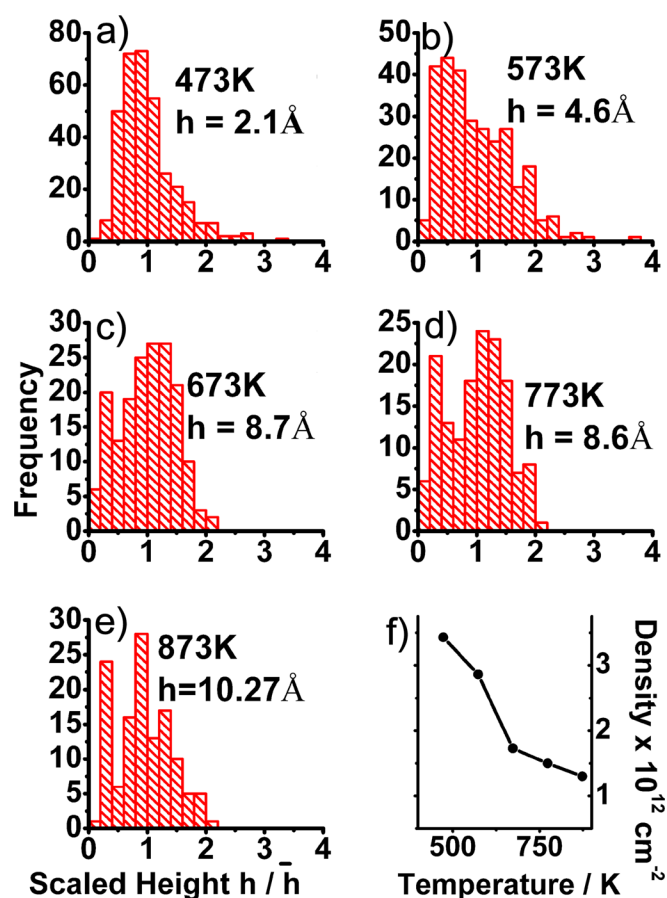


FIG. 3. (Color online) Measured island size and density distributions of the Cu nanoparticles as a function of annealing temperature. The histograms [(a)–(e)] use the scaled height of the particles for ease of comparison of the distributions in which the actual height (h) is divided by the mean for that distribution (\bar{h}). The mean height values for each temperature are given in the histograms. (f) shows the development of the measured surface density of nanoparticles as a function of annealing temperature.

histograms show the frequency of occurrence of particles as a function of scaled height. Apparent height is the most reliable dimensional measurement on nanoparticles in this size regime as lateral lengthscales are convoluted with the shape of the tip, which has a radius at least comparable to the particle dimension—not least because the tip tends to pick nanoparticles up. Hence, we use apparent height as the dimension to describe the size of the particles. Scaled height, where the apparent height of each particle is divided by mean heights for the distribution, allows us to compare the shapes of particle size distributions. The mean height at each temperature is given on the histograms along with the particle density in the last panel. For all images, we have only included the Cu nanoparticulate structures in the analysis; on the 473 K images, the graininess of the film hampers the height measurements of these smallest particles and between 673 and 873 K, the disordered secondary background structure is ignored. The initial distribution is narrow with a significant tail beyond twice the mean size. The mean apparent height at 473 K is approximately the size one would expect for a Cu dimer or single molecule on a geometric basis (ignoring electronic structure effects). The mean apparent height is almost constant between 673 and 773 K which is surprising as the particles are ripening and should be growing in average size. However, a simple explanation is that the particles are simply changing shape and that a change in volume may lead to a slower growth in height in some regimes as the islands spread laterally. The small size of the nanoparticles precludes the imaging of facets. Even the largest islands at 873 K appear to only contain 6500 atoms, so these are unlikely to show well defined facets as each side of the structure would only have a ~ 20 atoms and hence it reasonable to assume a hemispherical shape.²

As the particles grow, the distribution between one and two mean radii grows significantly becoming the dominant population at 773 K and the total width of the distribution narrows to twice the mean radii. A significant number of relatively small particles remain at 873 K leading to a bimodal

distribution. The apparent volume of Cu derived from the STM images of the particles at 473 K is $\sim 8 \times 10^{13}$ Cu atoms cm^{-2} , rising to $\sim 3.4 \times 10^{14}$ cm^{-2} at 573 K, where the particle height can be measured better due to visible substrate. At 673 and 773 K, this number is constant at $\sim 5.5 \times 10^{14}$ cm^{-2} , while it jumps up to 8.3×10^{14} cm^{-2} after the 873 K anneal. The overestimation of particle volume is common in STM due to tip shape convolution of the particles lateral extent and the inability to measure voids underneath overhanging edges or a particle—for example, nonwetting spherical particles or those with facets.

C. Photoemission

In Fig. 4, we show the XPS results for RT adsorption on the (1×1) terminated surface taken through a sequence of annealing steps which allows us to relate the topography seen in STM to chemical species. Upon adsorption at 298 K, the XPS shows C 1s spectra in three states as expected corresponding to 285.2 eV C–H, 288.7 eV C=O, and 292.8 eV C–F₃; F in two states with 90% of the signal deriving from the F in the 688.5 eV CF₃ groups and the remainder at higher binding energy (692 eV) assigned to F bound to the surface; and the presence of Cu in the +1 oxidation state at 933.0 eV. As the annealing temperature increases, the C 1s spectra changes significantly with a decline of the highest binding energy feature by 573 K and of the central peak at 773 K. At 873 K, the lowest binding energy feature shifts slightly in energy to 284.5 eV. The fluorine 1s spectra simply show a gradual decline in the intensity of the main feature with just the residual F bound to the surface signal remaining at 873 K. The Cu 2p spectra show a single peak with a shift in binding energy and broadening after annealing to 373 K and then a gradual change to slightly lower binding energy with subsequent annealing.

D. Discussion

The deposition of Cu^{II}(hfac)₂ from the vapor phase onto TiO₂(110) at RT is characterized by the chemisorption of the

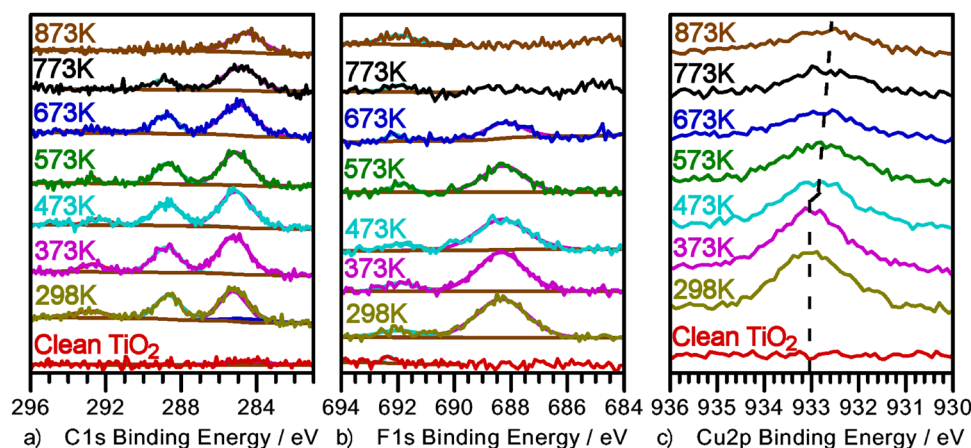


Fig. 4. (Color online) XPS data taken for the Cu^{II}(hfac)₂ adsorbed on a (1×1) terminated surface and annealed for the same temperatures as the STM images. (a) shows the C 1s photoemission and three peaks characteristic of the molecule at 285.2 eV C–H, 288.7 eV C=O, and 292.8 eV C–F₃; (b) shows the F 1s spectra and two peaks due to the molecules C–F₃ groups and a minor fragment from F adsorption on the TiO₂; (c) shows the Cu 2p_{3/2} signal due initially to Cu^I below 473 K and subsequently increasingly due to Cu⁰ in metallic nanoparticles.

molecule. The XPS results and STM images indicate the copper is oxidized and that a homogenous layer of the adsorbate forms. After annealing to 373 K, there is little to no change in the spectra, but by 473 K, the Cu 2p_{3/2} peak broadens and shifts closer to the value associated with metallic copper. The STM images at this temperature show a grainy textured background and small nanoparticles. We believe the background is due to the adsorbed Cu^Ihfac, hfac ligands, and small Cu clusters, whereas the nanoparticles are composed of Cu metal. Further annealing at higher temperatures drives off most of the ligands and the nanoparticles grow in size. The XPS shows a gradual shift toward the metallic state for all Cu in the spectra and a reduction in intensity as expected for the formation of compact clusters in comparison to a dispersed film. The breadth of the peak arises from the Cu in two states, as Cu^I and as Cu metal, which we cannot resolve with an unmonochromated x-ray source. At 873 K, the Cu nanoparticles co-exist on the surface with a grainy 3–4 Å disordered structure. The XPS shows that at this temperature, the only species left on the surface aside from Cu is a carbon residue, probably in the form of titanium oxy-carbide.¹⁷ At the higher temperatures, a number of small pits become apparent on the surface which may be due to reaction of adsorbed hydrocarbons to form H₂O and CO/CO₂.

It is peculiar that Cu deposited from an adsorbed precursor has no tendency to aggregate at atomic scale step edges on the surface yet Cu deposited by physical vapor deposition on the (1 × 1) surface shows a very strong preference for the steps.¹⁶ However, it should be noted that on a partially reconstructed (1 × 2) surface, this effect is far less noticeable and a nanoparticle density approaching the defect density on the terraces arises.¹⁸ It would appear that in the Cu^Ihfac cross linked TiO₂ precursor–substrate system, where the cross-links of the (1 × 2) reconstruction can nucleate island growth,¹² that the Cu islands do not prefer to nucleate on these sites or the step edges. Instead a very uniform array of small particles forms initially because the adsorption site for the molecules determines the structure. It is the slow release of Cu to form small Cu clusters co-adsorbed with the ligands which then ripen into a bimodal distribution. The origin of the bimodal size distribution probably arises due to the surface heterogeneity induced by the crosslinks of the reconstruction which can pin Cu particles and reduce mobility. As the particle distribution ripens at elevated temperature mobile unpinned Cu (adsorbed between the crosslinks) will aggregate onto pinned clusters at the crosslinks. At a characteristic size for the given temperature larger islands could depin and become more mobile rapidly mopping up neighboring material leading to large islands. The larger structures would show a greatly reduced mobility and appear sitting in a denuded region while most of the surface is still covered with smaller pinned clusters. Indeed the larger particles

appear to be well separated in the images [Figs. 2(c)–2(e)]. The influence of the ligand fragments may also play a role in pinning clusters or reducing adatom and cluster mobility which may offer a method to induce homogeneous nucleation and growth in ALD if this effect could be controlled.

IV. SUMMARY AND CONCLUSIONS

We have studied the adsorption of Cu^{II}(hfac)₂ on the surface of a model oxide system, TiO₂(110), and probed the molecular stability with respect to thermal cycling. We find that at 473 K the adsorbed molecules begin to dissociate and release Cu atoms which aggregate and form Cu nanoparticles. These Cu nanoparticles ripen over time and the size (height) distribution develops into a bimodal distribution. Unlike some other organometallic systems, which show a bimodal distribution due to enhanced nucleation at surface step edges,¹⁹ the nanoparticles do not preferentially form at steps.

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